Electronic Patent Application Fee Transmittal							
Application Number:	10669671						
Filing Date:	23-Sep-2003						
Title of Invention:	METHODS OF FILLING GAPS AND METHODS OF DEPOSITING MATERIALS USING HIGH DENSITY PLASMA CHEMICAL VAPOR DEPOSITION						
First Named Inventor/Applicant Name:	Neal R. Rueger						
Filer:	Jennifer J. Taylor/Jaime White						
Attorney Docket Number:	MI22-2145						
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Utility Filing Fees							
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Basic Filing:							
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